



MAIL STOP RCE  
PATENT  
8040-1052

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Taishi KUBOTA et al.

Conf. 8011

Application No. 10/763,244

Group 2823

Filed January 26, 2004

Examiner Trung Q. Dang

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE  
AND OXIDIZATION METHOD OF SEMICONDUCTOR  
SUBSTRATE

AMENDMENT

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 14, 2005

Sir:

In response to the Official Action mailed July 13, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.